APR 1 5 2002

Case No.: 54888US006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor:

YAMANAKA, KEIZO

Application No.:

10/009,308

Group Art Unit:

Unknown

Filed:

November 12, 2001

Examiner:

Unknown

Title:

APRICE NAIL PRESSURE SENSITIVE ADHESIVE SHEET AND PRODUCTION

METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on:

Dear Sir:

Pursuant to 37 CFR §1.56 and §1.97-1.98, enclosed please find a completed Form PTO-1449 citing reference submitted for consideration by the Examiner during examination of the above-referenced patent application. Copies of the references listed on the enclosed Form PTO-1449 are enclosed.

Applicants request consideration of these references by the Examiner in regard to the present application, and that the Examiner initial and return the enclosed Form PTO-1449.

It is believed that no fee is due in connection with this Information Disclosure Statement: however, if any such fee is due, please charge to Deposit Account No. 13-3723.

Respectfully submitted,

Melanie Gover, Reg. No.: 41,793

Telephone No.: 651-736-6432

Office of Intellectual Property Counsel 3M Innovative Properties Company P.O. Box 33427

St. Paul, MN 55133-3427 Facsimile No.: 651-736-3833

BEST AVAILABLE COPY

BEST AVAILABLE COPY

OMB No. 0651-0011 Atty. Docket No. INFORMATION 4888US006 Serial No.: 10/009,308 **DISCLOSURE** Applicant(s): Keizo Yamanaka, Tatsuo Fukushi and **STATEMENT** Yorinobu Takamatsu Filing Date: November 12, 2001 Group: Unknown **U.S. PATENT DOCUMENTS** Examiner **Document Number** Date Name Class SubClass Filing Date If Initial Appropriate RE24,906 12/13/60 Ulrich 2,956,904 10/18/60 Hendricks 3,133,854 05/19/64 Simms 3,252,880 05/24/66 Magat et al. 3,810,874 Mitsch et al. 05/14/74 4,181,752 01/01/80 Martens et al. 4,230,768 10/28/80 Hamada et al. 4,329,384 05/11/82 Vesley et al. 4,472,480 09/18/84 Olson 4,533,566 08/06/85 Evans et al. 4,563,388 01/07/86 Bonk et al. 4,567,073 01/28/86 Larson et al. 4,614,667 09/30/86 Larson et al. 4,740,562 04/26/88 Menke et al. 4,743,300 05/10/88 Brinduse et al. 4,820,588 04/11/89 Brinduse et al. 4,830,910 05/16/89 Larson 4,861,408 08/29/89 Kelber (counterpart of U.S. 7,036,039) 4,873,140 10/10/89 McIntyre 4,981,727 01/01/91 Brinduse et al. 5,209,971 05/11/93 Babu et al. 5,209,972 05/11/93 Super et al. 5,266,400 11/30/93 Yarusso et al. 5,306,758 04/26/94 Pellerite 5,482,991 01/09/96 Kumar et al. FOREIGN PATENT DOCUMENTS Date of Document Number Country Class SubClass Translation Publication Yes No 49-29613 08/06/74 Japan X 0 523 644 B1 11/12/97 **EPO** 868463 05/17/61 Great Britain 10-58617 03/06/89 Japan w/English Abst 2209928 Japan w/English Abst 08/21/90.

APR 1 5 2002

				APR 1 5 2002			
		Ta 00000		7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7 7			
 	- \- \- \- \- \- \- \- \- \- \- \- \- \-	2-28239	01/30/90	Japan W/English Abst	3	7	
	 `	3-163182	07/15/91	Japan w/English Abst	-		
	/	3-250034	11/07/91	Japan w/English Abst	1 2 2	-X	
·	1 2	4146129	05/20/92	Japan w/English Abst	7	7	
	V	5-8353	01/19/93	Japan w/English Abst	7.	P 1	
		6131411	02/13/86	Japan w/English Abst	- John San	100	
		61-7337	01/14/86	Japan w/English Abst		1	
		/8-245850	09/24/96	Japan w/English Abst		100	
		08-073819	03/19/89	Japan w/English Abst		+	
	V	63-150330	06/23/88	Japan w/English Abst		+	
						+	
	OTHE	R DOCUMENTS (In	cluding Aut	hors, Title, Date Perti	nent Denove etc.)	┸─┤	
		Paciorek et al., "Mechanism of Amine Crosslinking of Fluoroelastomers. I. Solution Studies," J. Polym. Sci., 45, 405-413 (1960)					
	V						
i		Schonhorn et al., "A	dhesive Bond	sive Bonding of Polyvinylidene Fluorido: Effect of Co.			
ĺ		Agent in PVF ₂ Surface Modification," <u>J. Adhesion Sci. Technol.</u> , 4, 277-290					
		(1989)					
	Makuuchi et al, "Effect of Evolved Hydrogen Fluoride on Radiation-Induced						
		Crosslinking and Dehydrofluorination of Poly(Vinylidene Fluoride)," J. Poly. Sci.,					
		<u>1 617. Chem. Ed.</u> , 14, 617-625 (1976)					
		L. Sidney et al., "Electron Beam and Gamma Fluoroelastomers." Proceedings of					
		Rad Tech Asia '91, Osaka, Japan (April 15-18, 1991).					
				10, 1771).			
EXAMINER				Date Considered			
				- a.c considered			
* F	1		/			1	

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Based on Form PTO-FB-A820 (Also form PTO-1449)

Patent and Trademark Office, U.S. Department of Commerce

BEST AVAILABLE COPY